

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Nobuyuki ISHIWATA et al.

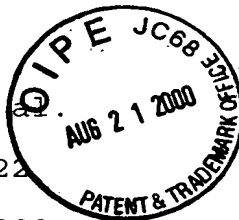
Serial No. 09/204,222

Filed December 3, 1998

Group 2754

Examiner W. Klimowicz

MAGNETO-RESISTANCE EFFECT
TYPE COMPOSITE HEAD AND
PRODUCTION METHOD THEREOF



RECEIVED
PATENTS

AUG 28 2000

TC 2700 MAIL ROOM

#10/B
Ampt
8/29/00
OC

AMENDMENT

Commissioner for Patents

Washington, D.C. 20231

Sir:

Responsive to the Official Action dated April 21, 2000, please amend the above-identified application as follows:

IN THE ABSTRACT:

Rewrite the Abstract of the Disclosure as on the accompanying separate sheet.

IN THE SPECIFICATION:

Page 1, line 13, cancel "reduction".

Page 9, line 13, cancel "an insulation film";

line 14, cancel "117, a TMR film, and".

Page 15, line 8, delete "to perform".

IN THE CLAIMS:

Amend claim 1 as follows:

--1. (amended) A magneto-resistance effect type composite head comprising:

09204222
09/01/2000 CCLES 00000003 250120
01 FC:102
02 FC:103

B1 Sub D

B